

MR3029-77

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: YAO-SHENG HSU

Serial No: 10/611,896 : Art Unit # 2811

Filed: 3 JULY 2003: Examiner:

Title : THIN FILM TRANSISTOR STRUCTURE AND : T. F. Tran

MANUFACTURING METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT

Mail Stop RCE Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The Applicants wish to make the following art references of record in the above-identified Patent Application pursuant to 37 C.F.R. §§ 1.97 and 1.98, and to the Duty of Disclosure set forth in 37 C.F.R. § 1.56.

Although the information submitted herewith may be "material" to the Examiner's consideration of the subject Patent Application, this submission is not intended to constitute an admission that such information is "prior art" as to the claimed invention.

In accordance with 37 C.F.R. § 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search was made or that no other material information, as defined in 37 C.F.R. § 1.56(b), exists.

MR3029-77 Appl. No. 10/611,896

The cited references are:

| Ref. No. | Patent Document No. | Date | Applicant | Translation |
|--------------------|---------------------|------------|--------------|---------------|
| Α | JP2000-194012 | 07-14-2000 | Fujitsu Ltd. | Abstract only |
| $\cdot \mathbf{B}$ | JP2000-314897 | 11-14-2000 | Hitachi Ltd. | Abstract only |

This Information Disclosure Statement is being filed concurrently with a Request for Continued Examination (RCE), and before the mailing of an Office Action subsequent to the RCE.

A Form PTO-1449 and copies of the references are submitted along with this document. It is requested that the Examiner consider the references and make them of record in the above-referenced Patent Application.

Respectfully submitted,

FOR: ROSENBERG, KLEIN & LEE

David I. Klein

Registration #33,253

Dated: 26 May 2006

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Sheet 1

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

| Complete if Known | | | |
|------------------------|---------------------|--|--|
| Application Number | 10/611,896 | | |
| Filing Date | 3 JULY 2003 | | |
| First Named Inventor | YU-CHOU LEE, ET AL. | | |
| Art Unit | 2811 | | |
| Examiner Name | T. F. TRAN | | |
| Attorney Docket Number | MR3029-77 | | |

| | | | U. S. PATENT D | OCUMENTS | |
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| Examiner Initials* | Cite No.1 | Document Number | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
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| Examiner Initials* | Cite No.1 | Foreign Patent Document | Publication Date | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages | |
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| · | В | JP2000-314897 | 11-14-2000 | HITACHI LTD. | | |
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| Signature | Conside | red |

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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.